

00684.002980.1



IFW
#5

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Osamu KAKUCHI et al.

Application No.: 10/620,389

Filed: July 17, 2003

For: EXPOSURE APPARATUS WITH
INTERFEROMETER

)
: Examiner: P. J. Connolly
)
: Group Art Unit: 2877
)
: Confirmation No.: 8110
)
:
)
: January 21, 2005

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	12	MINUS	27	= 0	x \$25 \$50	\$0.00
INDEP. CLAIMS	8	MINUS	5	= 3	x \$100 \$200	\$600.00
Fee for Multiple Dependent claims \$180/\$360						\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$600.00

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.



A check in the amount of \$600.00 is enclosed.



Charge \$_____ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.



Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.



A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.



A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.



Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Steven E. Warner

Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO

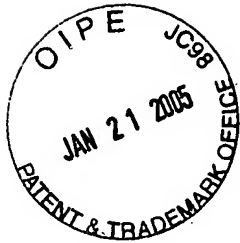
30 Rockefeller Plaza

New York, New York 10112-3801

Facsimile: (212) 218-2200

SEW/eab

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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
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AMENDMENT

Sir:

In response to the Official Action dated October 21, 2004, please amend the above-identified application as follows:

01/25/2005 MHEKONEN 00000068 10620389

01 FC:1201

600.00 DP